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PATENT
5298-06900 (PM01027)IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Schwarz et al.

Serial No. 10/074,888

Filed: February 13, 2002

For: REDUCING DEFECT FORMATION
WITHIN AN ETCHED
SEMICONDUCTOR TOPOGRAPHYGroup Art Unit: 1765
Examiner: Duy Vu Nguyen Deo

Atty. Dkt. No. 5298-06900

I hereby certify that this correspondence is being transmitted via facsimile or deposited with the U.S. Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313, on the date indicated below:

3/22/05
Date

Kevin L. Baffer

RESPONSE TO NOTICE OF ABANDONMENT MAILED MARCH 11, 2005

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313

Dear Sir:

Applicants hereby submit this Response to the Notice of Abandonment mailed on March 11, 2005. The Notice of Abandonment indicates the application went abandoned due to failure to timely file a response to the Office letter mailed on July 23, 2004.

Applicants transmitted via facsimile on October 13, 2004 a Request for Continued Examination (RCE) in response to the Advisory Action mailed September 23, 2004. Attached is a copy of the RCE along with a copy of the Auto-Reply Facsimile Transmission which evidences receipt of the RCE.

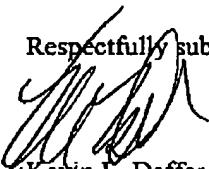
Upon closer review of the faxed RCE, Applicants note a typographical error in one number of the serial number. The RCE recites application number 10/174,888 instead of the correct application number 10/074,888.

Applicant respectfully petitions for entry of this RCE in the correct application number 10/074,888 and requests that the Notice of Abandonment withdrawn.

1/4

The Commissioner is authorized to charge the required fees to Daffer McDaniel, LLP Deposit
Account Number 50-3268/5298-06900.

Respectfully submitted,



Kevin L. Daffer
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Date: 3/22/05